EAST Search History

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#	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	206	(257/59 or 257/72 or 257/412). ccls. and (gate same (melt\$3 adj point)) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 17:34
L2	304	(349/139 or 349/146 or 349/147). ccls. and ((gate adj (electrode or line)) with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multiple or three or "3" or laminat\$3 or ((Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten)))) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON .	2006/03/28 17:43
L3	1420	(257/59 or 257/72 or 257/412). ccls. and ((gate adj (electrode or line)) with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multiple or three or "3" or laminat\$3 or ((Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten)))) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 17:47
L4	4	(349/46).ccls. and (gate with (melt\$4 adj point)) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT.	OR	ON	2006/03/28 18:07
L5	114	(349/46).ccls. and ((gate adj (electrode or line)) with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multi-layer\$3 or multiple or three or "3" or laminat\$3 or ((Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten)))) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON ·	2006/03/28 18:08

EAST Search History

L6	418	(349/139 or 349/147 or 349/148). ccls. and (gate with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multi-layer\$3 or multi-layer\$3 or multiple or three or "3" or laminat\$3 or ((Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten)))) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 18:54
L7	116319	(semiconductor or LCD or display) and (gate with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multi-layer\$3 or multi-layer\$3 or multiple or three or "3" or laminat\$3 or ((Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten)))) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 18:55
L8	25585	(semiconductor or LCD or display) and (gate with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multi-layer\$3 or multi-layer\$3 or multiple or laminat\$3 or ((Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten)))) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 18:55
L9	6370	(semiconductor or LCD or display) and (gate with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multi-layer\$3 or multiple or laminat\$3)) and (Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten) and @ad<"20030219"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 18:57

EAST Search History

L10	1212	(semiconductor or LCD or display) and ((gate with (tri-layer\$3 or trilayer\$3 or multilayer\$3 or multi-layer\$3 or multi-layer\$3 or multiple or laminat\$3)) same (Al or Cu or Ag or aluminum or copper or silver) and (Mo or mo-W or moW or molybdenum or molybdenum-tungsten or mo near W or molybdenum near tungsten))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 20:58
L12	29	and @ad<"20030219" L10 and (Mo with (etch\$4 near2 rate))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 21:02
L13	31	L10 and ((Mo or molybdenum) with (etch\$4 near2 rate))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/03/28 21:03